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Bib Data Sheet

CONFIRMATION NO. 1427

SERIAL NUMBER 10/790,921	FILING DATE 03/02/2004 RULE	CLASS 438	GROUP ART UNIT 2891	ATTORNEY DOCKET NO. SAM-0563
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APPLICANTS

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** CONTINUING DATA ***** None AICS

** FOREIGN APPLICATIONS ***** Yes AICS
 REPUBLIC OF KOREA 03-14406 03/07/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 05/22/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>Asst. Minna Sarhan</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 13	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 3
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TITLE
 Method for forming a metal silicide layer in a semiconductor device

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